Work supported by INFN CSN5 experiment SAMARA and INFN CSN1 experiments SRF and RD_FCC

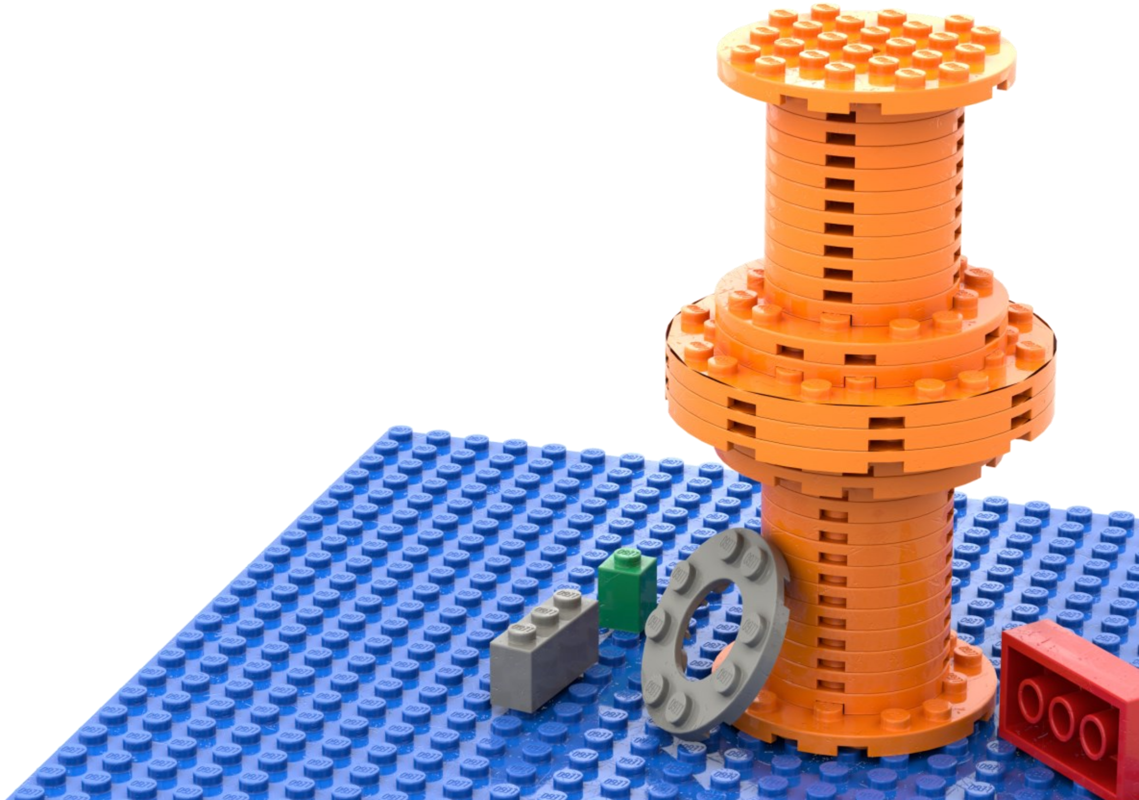
This project has received funding from the European Union's Horizon-INFRA-2023-TECH-01 under GA No 101131435 – iSAS and from the European Union's Horizon 2020 Research and Innovation programme under GA No 101004730 – I.FAST

Roma 6-7 Maggio 2024
Centro Congresso Frentani

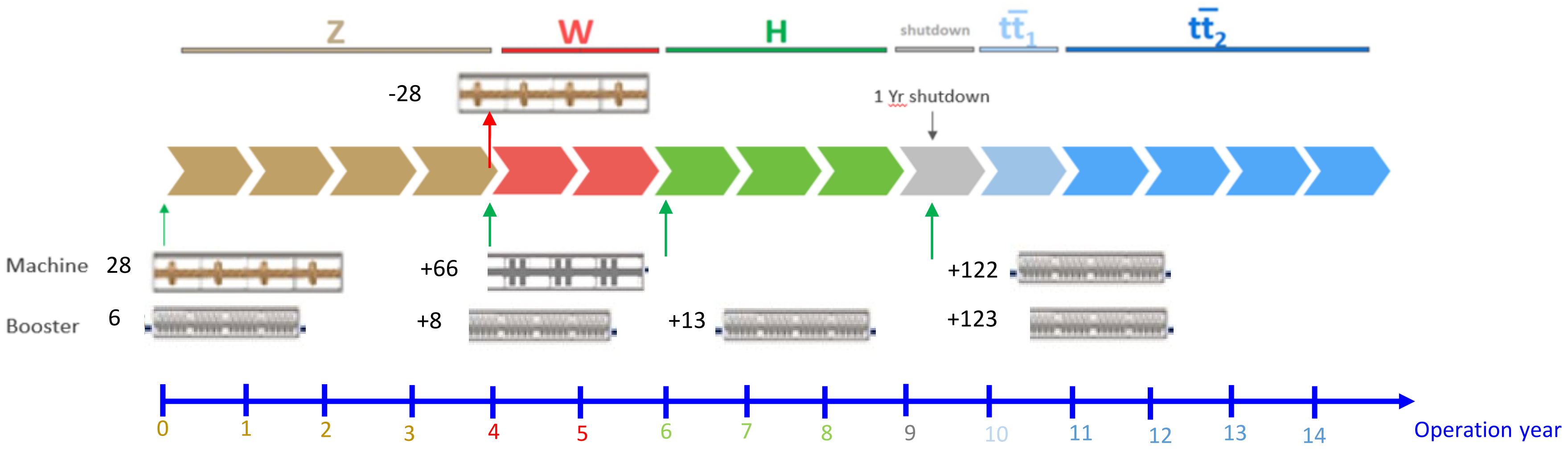
INFN LNL

Cristian **Pira**

Development of Thin Film SRF relevant for FCC



SRF System Baseline for FCC



In total: 366 CM, 1'464 cavities (4 cavities/CM, present assumption):

- **400 MHz single-cell (Nb/Cu): 28 CM, 112 cavities → 4.5 K** *(to be removed after Z)*
- **400 MHz two-cell (Nb/Cu): 66 CM, 264 cavities → 4.5 K**
- 800 MHz five-cell (bulk Nb): 272 CM, 1'088 cavities → 2 K

Collider (ttbar2): 188 CM (264 cavities 400 MHz, 488 cavities 800 MHz)

Booster (ttbar2): 150 CM (600 cavities 800 MHz)

Performance of thin film 400 MHz are one of the main challenges of FCC SRF System

SRF System Baseline from Vittorio Parma, FCC week 2023

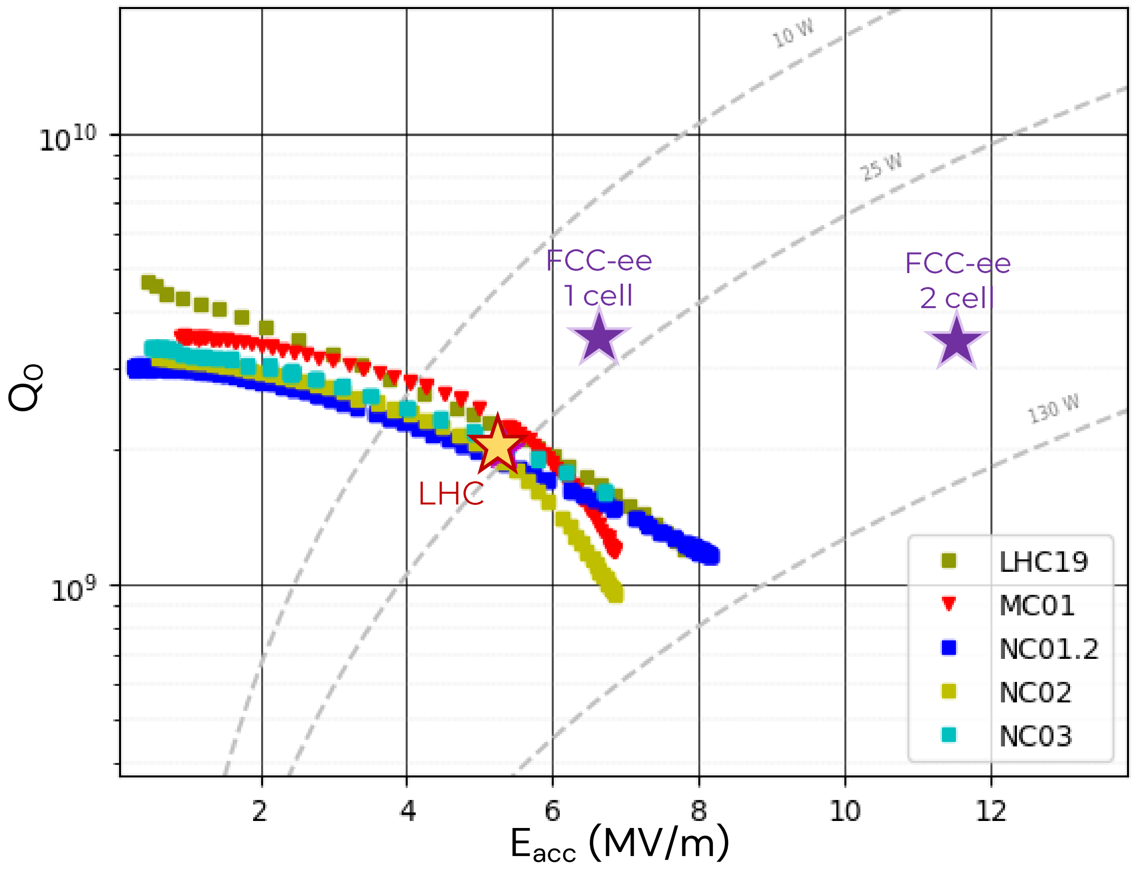
400 MHz requirements

FCC-ee requires
higher cavities performances than LHC

Nb on Cu "baseline", Solid scheme with good margin for reliable operation Clear R&D paths identified (seamless copper cavities, HiPIMS coating, High Q0 bulk Nb cavities)

Franck Peauger , FCC week 2023

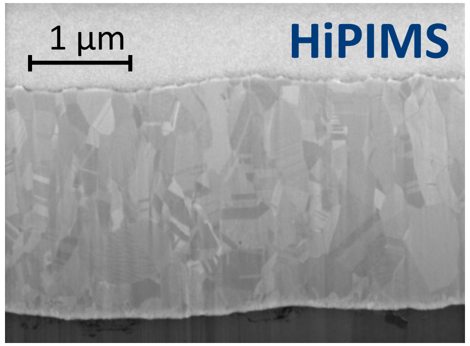
LHC cavities Q vs E_{acc} @4.5 K

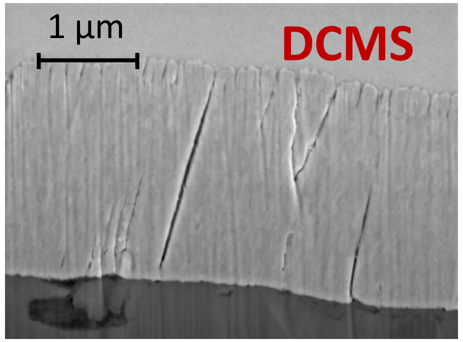


Graph from Carlota Pereira Carlos, FCC week 2023

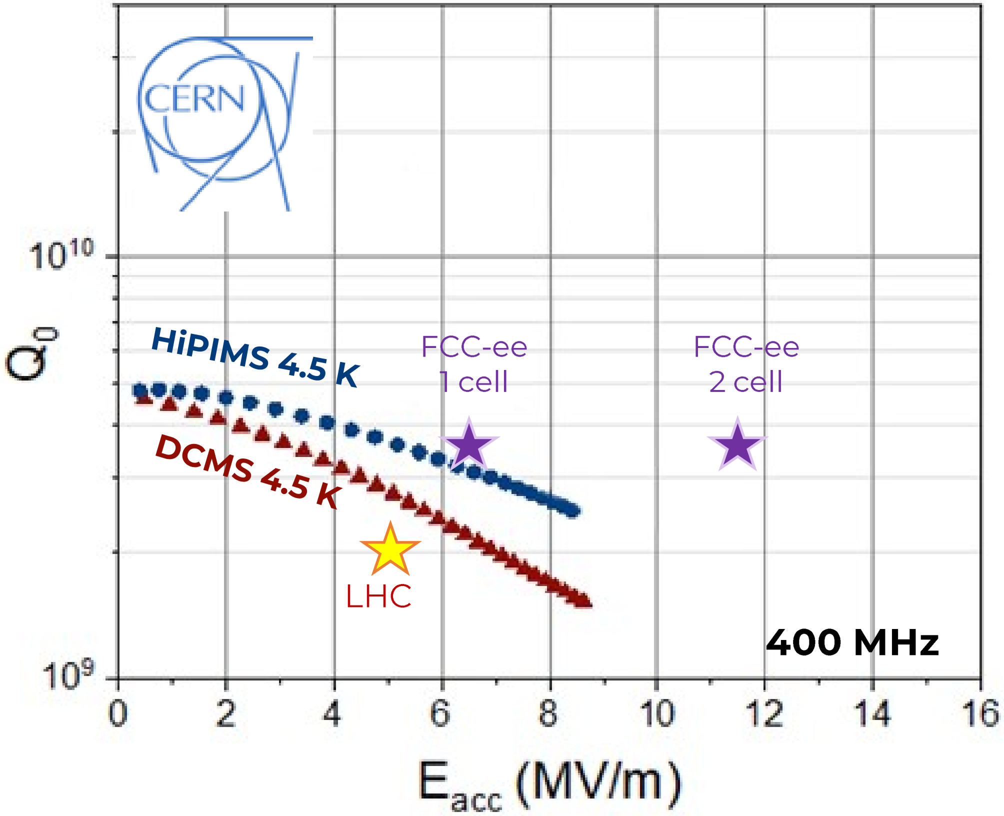
SRF R&D @CERN for FCC

HiPIMS technology densifies the Nb coating and increases RF performances compared to DCMS



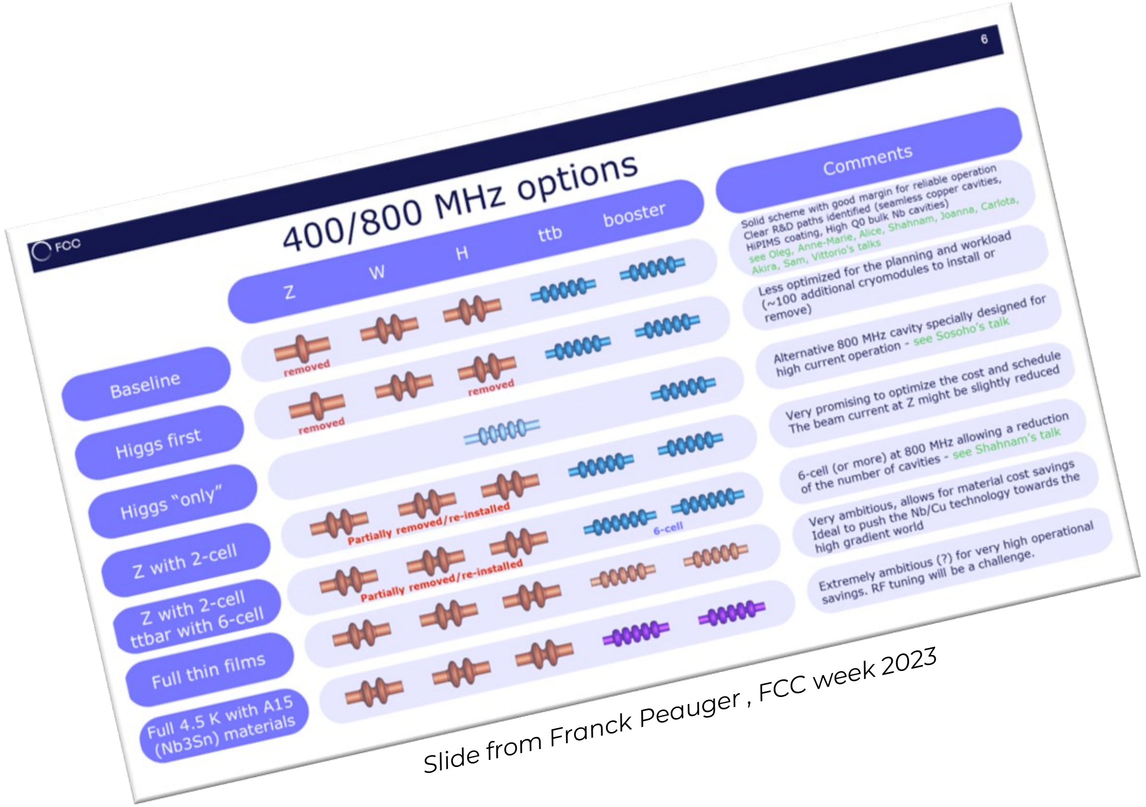


Carlota Pereira Carlos, FCC week 2023 (elaborated)



R&D @CERN also on cavity forming (hydroforming), polishing (EP), Cu oxide layer, Nb_3Sn by HiPIMS

Other Option for FCC SRF System



Slide from Franck Peauger , FCC week 2023

Full 4.5 K with A15 Materials → Nb_3Sn

Extremely ambitious
for very high operational savings

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INFN LNL SRF R&D focused on Nb_3Sn since 2021

The development of **Nb_3Sn on Cu** for SRF accelerating cavities is part of **European Strategy** for Particle Physics Accelerator - **R&D Roadmap**

INFN R&D started in a CSN5 experiment SAMARA
INFN CSN5 Experiment

*INFN LNL has a **leadership role** in the two main **European Projects** on Thin Film SRF R&D:* iFAST iSAS

*A **dedicated Project on R&D of interest of FCC** has been **financed by INFN board**:*

SRF cavities R&D for FCC-ee
INFN Accelerators European Strategy Program

RD_FCC
INFN CSN1 Experiment

International Partners:

CERN, cea, UKRI, Science and Technology Facilities Council, HZB Helmholtz Zentrum Berlin, HZDR Helmholtz Zentrum Dresden Rossendorf, Universität Siegen, IJCLab Irène Joliot-Curie Laboratoire de Physique des 2 Infinis, ELU, Rīgas Tehniskā Universitāte, Jefferson Lab, Fermilab, Piccoli

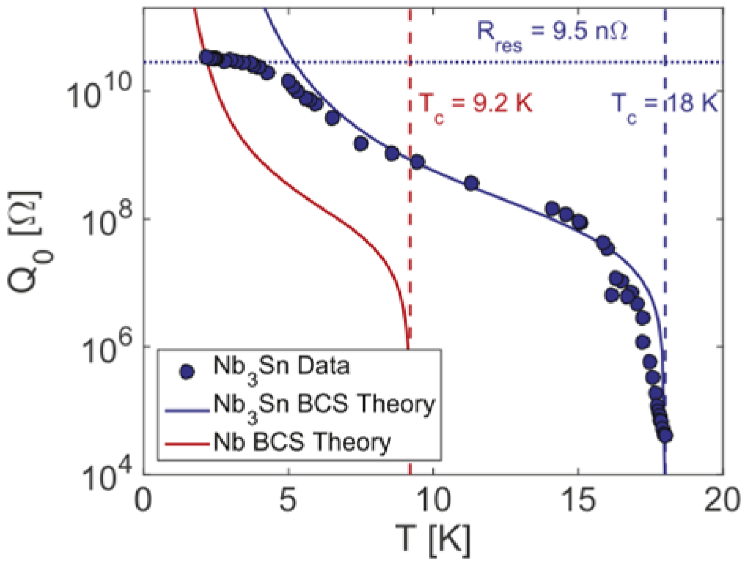
Nb_3Sn motivation

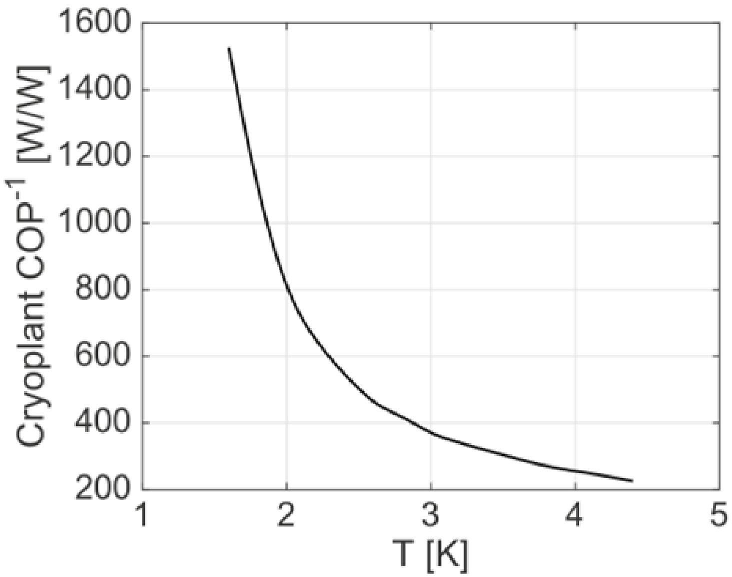
***Energy saving** is mandatory for **FCC-ee** and the **next generation accelerators**…*

*…**cryogenics** is one of the **larger energy cost** in modern SRF accelerators*

Move from bulk Nb @2K to Nb_3Sn @4.5 K

reduces cryogenic power by a factor of 3





Supercond. Sci. Technol. 30 (2017) 033004

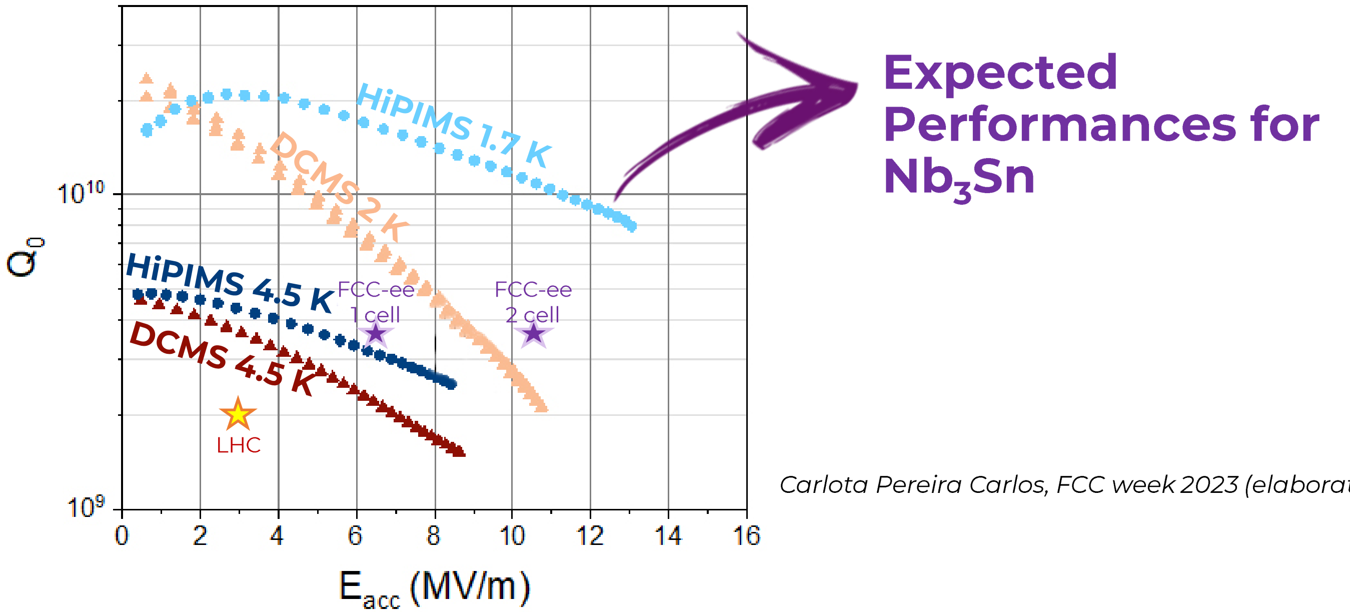
Nb_3Sn motivation

Energy saving *is mandatory for* ***FCC-ee*** *and the* ***next generation accelerators****…*

*…****cryogenics*** *is one of the* ***larger energy cost*** *in modern SRF accelerators*

Move from thin film Nb @4.5 K to Nb_3Sn @4.5 K

Reduce T_{op}/T_c → Suppress R_{BCS} → Increase Q



Carlota Pereira Carlos, FCC week 2023 (elaborated)

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Nb_3Sn on Cu: Multiple challenges

- A15 are Brittle materials
- Complicated Phase Diagram
- Low melting point substrate
- Interface diffusion
- Coating Parameters
- Substrate preparation
- Target Production/Magnetron Design
- Trapped Flux
- Tuning

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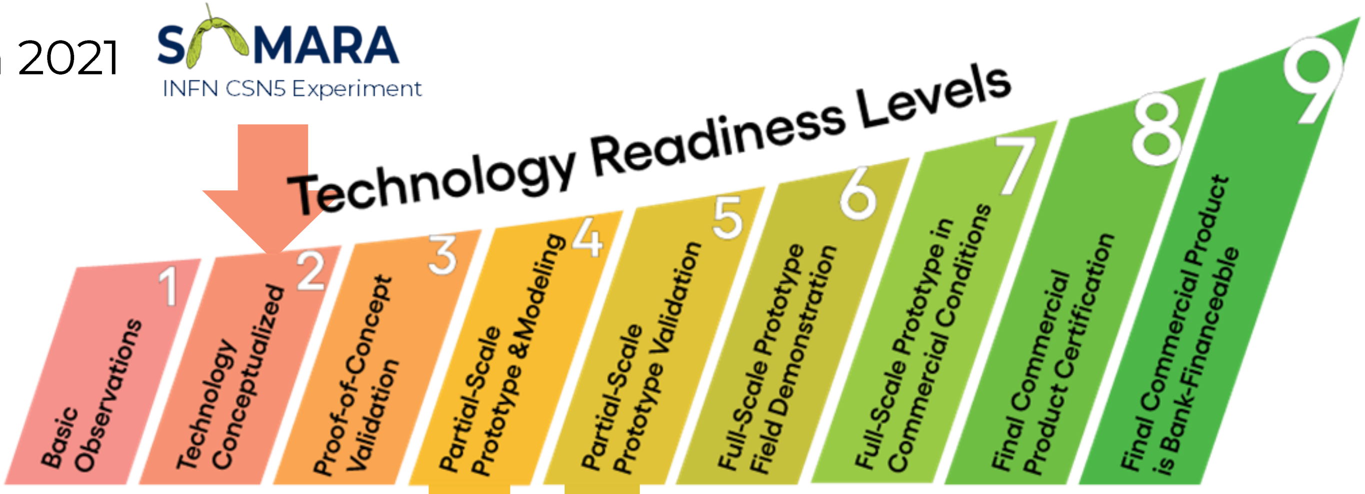
- **Substrate preparation**
- **Target Production/Magnetron Design**
- **Trapped Flux**
- **Tuning**

SRF cavities R&D for FCC-ee

INFN Accelerators European Strategy Program

TRL evolution

First test in 2021 SAMARA
INFN CSN5 Experiment



iFAST

MAIN GOAL (2025):
Produce a prototype of high performance 1.3 GHz thin film SRF elliptical cavity
$Q > 1\cdot 10^{10}$ @ 4.5 K

iSAS

SRF cavities R&D for FCC-ee

INFN Accelerators European Strategy Program

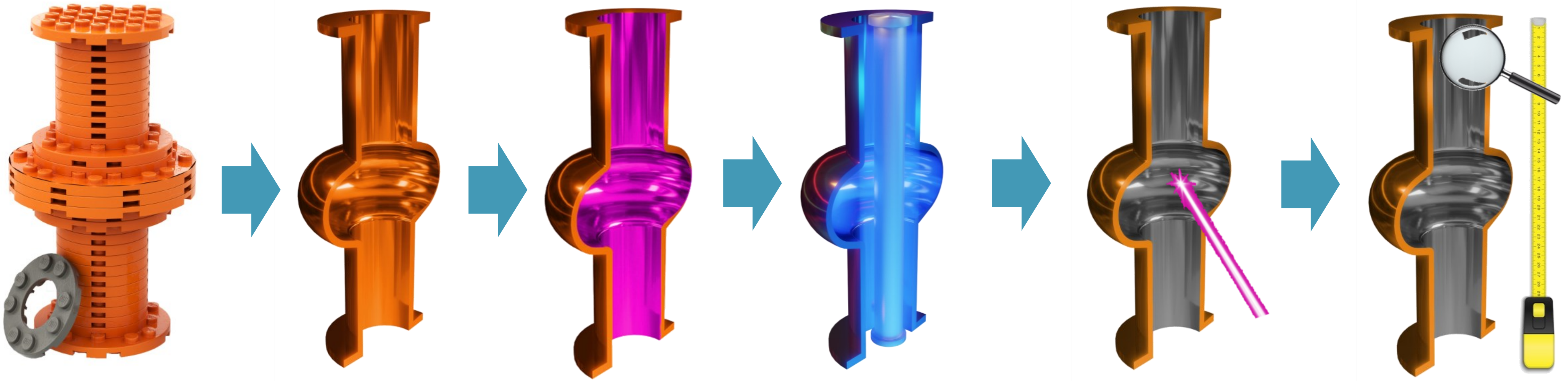
A step forward in TRL

Focus on:

- minimizing **trapped flux**
- increasing coating mechanical strength
(to allow **cavity tunability**)

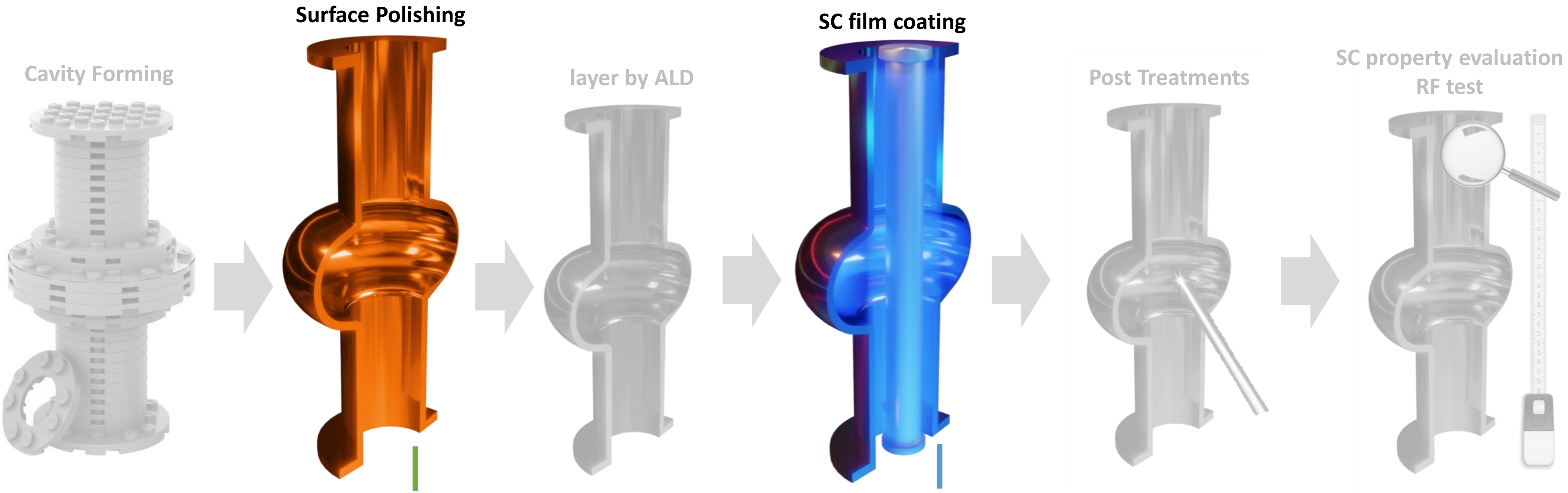
INFN LNL R&D activity covers all cavity production chain

Cavity Forming	Surface Polishing	layer by ALD	SC film coating	Post Treatments	SC property evaluation RF test



Seamless Spinning	*Plasma Electrolytic Polishing*	*Atomic Layer Deposition*	*Nb_3Sn on Cu*	*Laser Annealing*	
Additive Manufacturing				*Millisecond Flash Annealing*	

In SRF project 2 technologies are developed in prospective of FCC



Plasma Electrolytic Polishing

Nb_3Sn on Cu Coatings

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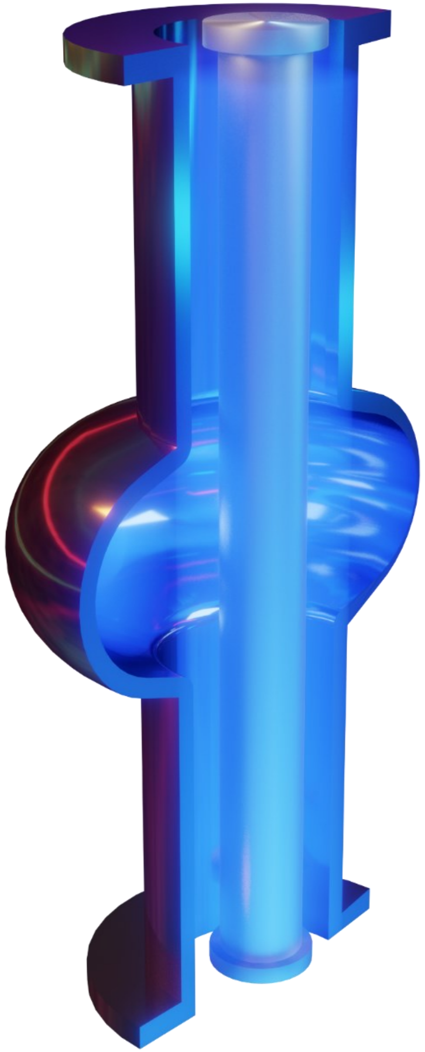
SRF Project is supported by CERN

- **The project has been defined through several meetings with Walter Venturini** (RF Group) and **Guillaume Rosaz** (Coating Group)
- **CERN will support and participate to the project via SRF R&D program**
- **A INFN-CERN MOU is in preparation**



Nb_3Sn on Cu Coatings

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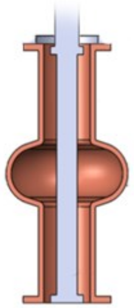
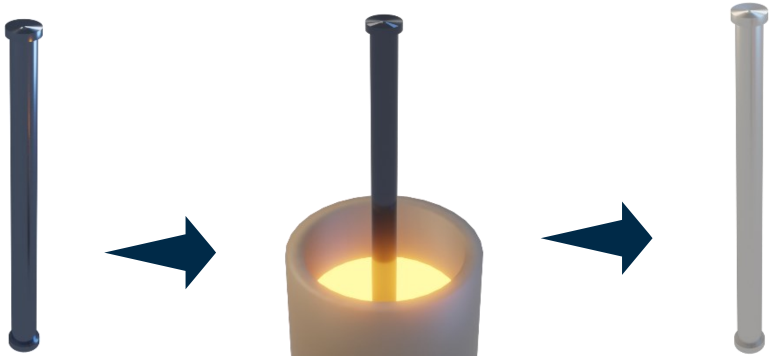
Nb_3Sn coatings: target production



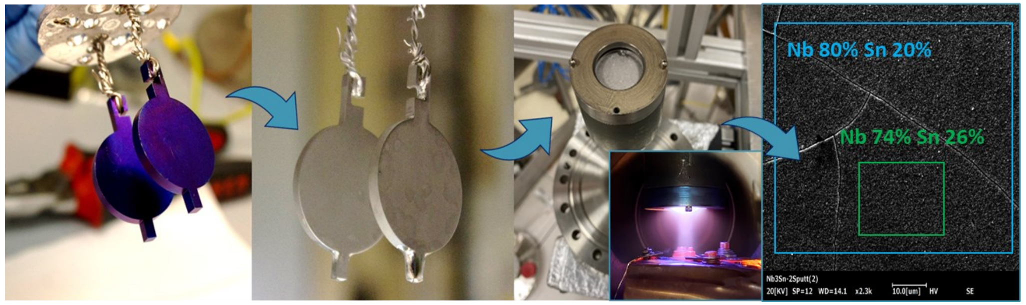
Single target configuration easiest to scale onto elliptical geometry

Nb_3Sn cylindrical targets are not commercially available

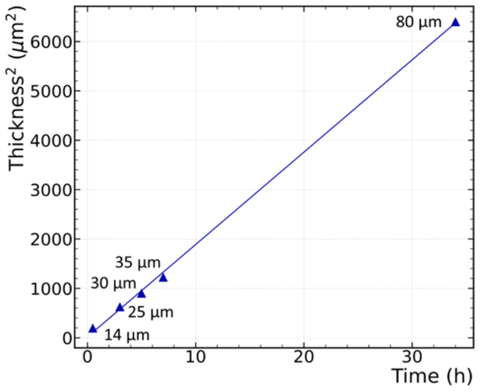
LNL Strategy for Nb_3Sn cylindrical targets production for 6 GHz cavities



Raw Nb target → ***Dipping in liquid Sn*** → *Nb_3Sn cylindrical target*



Proof of concept

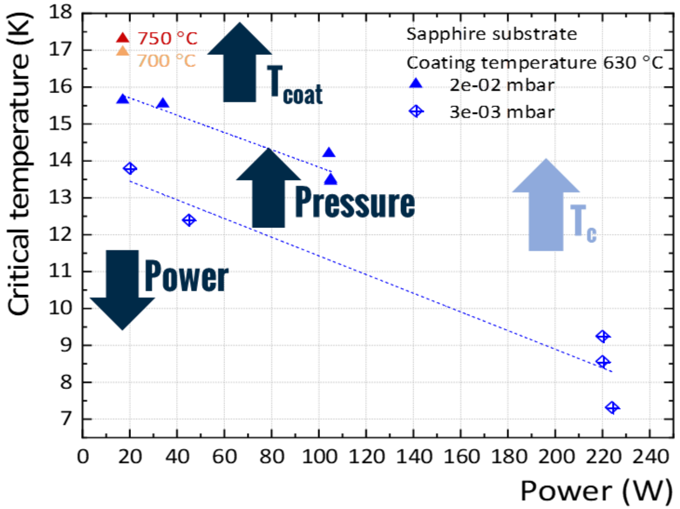


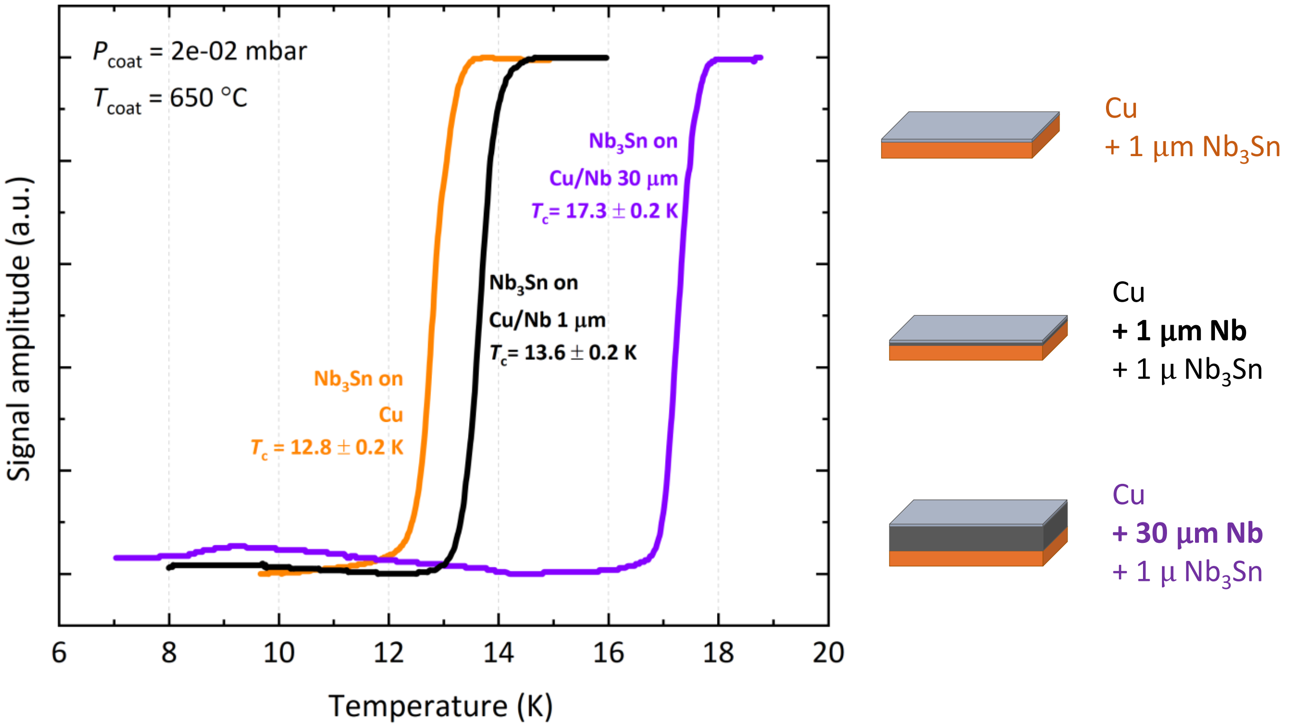
Nb_3Sn **thickness** related to **dipping time**

Possible **tin content modulation**

Nb_3Sn Coatings

Long R&D phase on PVD Parameter Optimization





Optimized Coating Recipe

- Coating Parameters:
  - Pressure = $2*10^{-2}$ mbar
  - Power = 16 W
  - T substrate ≥ 600 C
- **Nb Thick Barrier Layer > 30 um**

A thick Nb buffer layer accommodates the Nb_3Sn coating

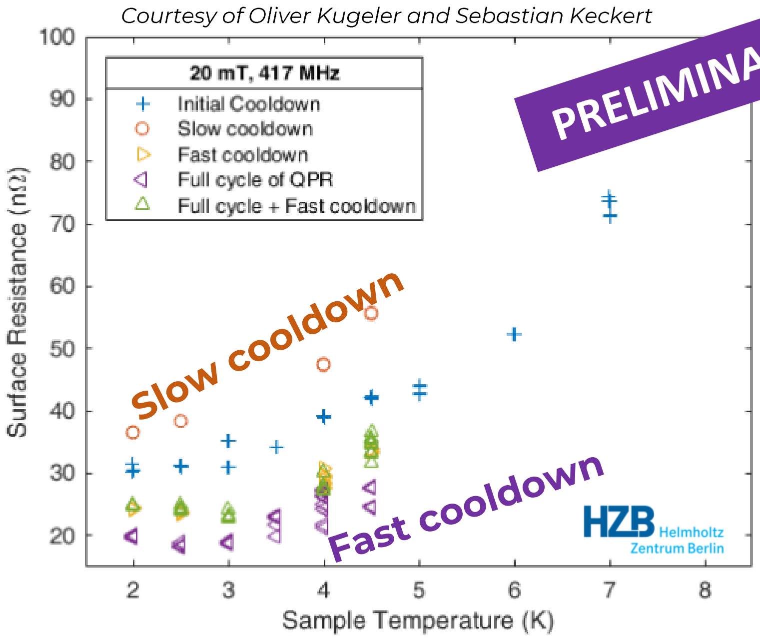
Nb substrate can be used to validate Nb_3Sn Coating Performances

First Nb_3Sn RF Results

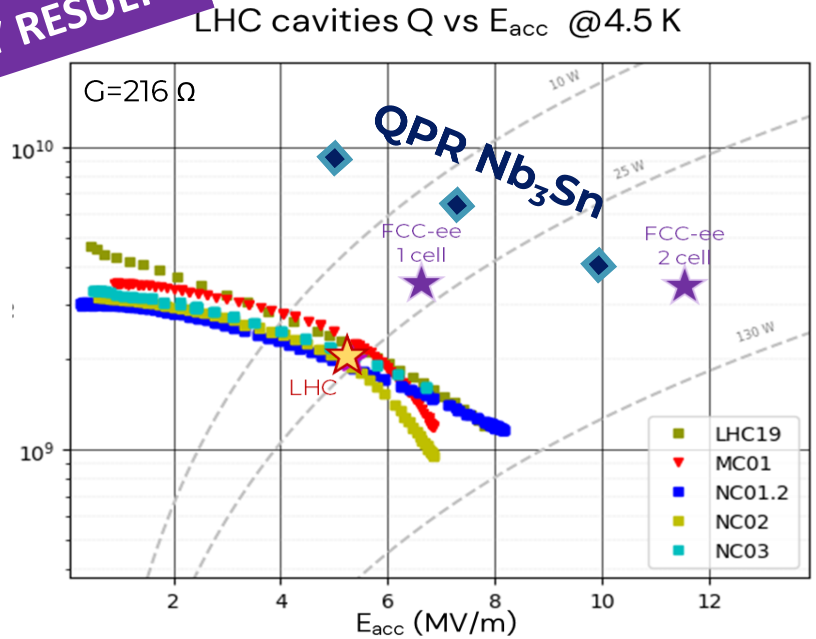
(on a small Nb planar resonator)

Rs of 23 nΩ
@ 4.5 K, 20 mT

Quench >70 mT
@ 4.5 K



PRELIMINARY RESULTS



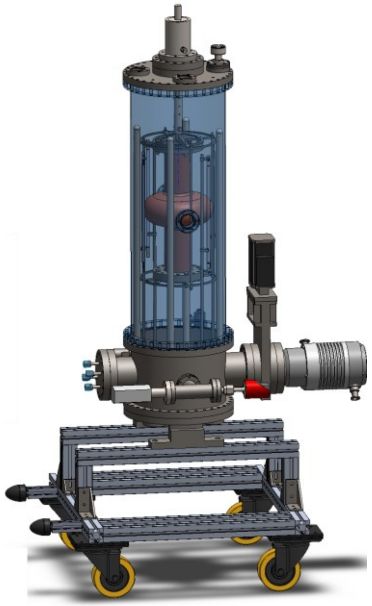
- **Nb_3Sn coating suffer flux trapping**
- **Cooldown procedure influence Rs**

Equivalent to a Q of $9{\cdot}10^9$ @5 MV/m @4.5 K

Almost 1 order of magnitude better than LHC!!!

Room for improvement

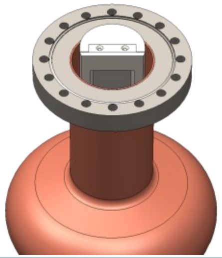
Nb_3Sn Path to Final Prototype



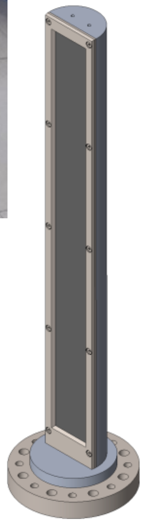
Nb_3Sn on bulk Nb to validate coating performances (2025)
on 1.3 GHz Elliptical Cavities (2025)

Develop Nb thick barrier/accommodation layer
on 1.3 GHz Elliptical Cavities (2025)
(proof of concept on 6 GHz cavities already done)

Nb_3Sn on Cu with thick Nb coating
on 1.3 GHz Elliptical Cavities (2026-2028)

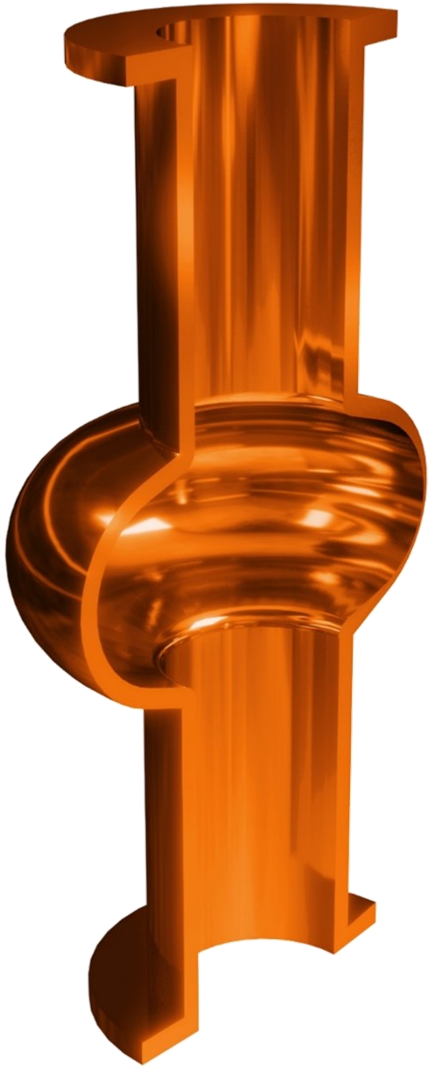


- **1.3 GHz Vacuum system ready**
- **Magnetron source commissioned**



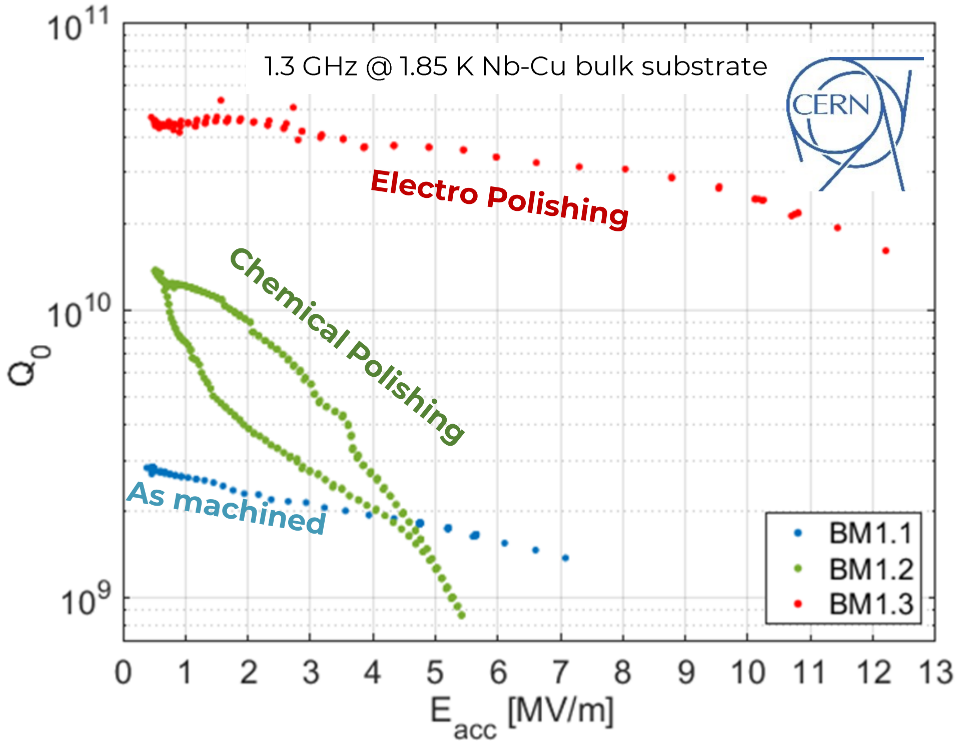
In parallel:

- *Study on alternative buffer layer* cea
- *Study on flux trapping* UKRI Science and Technology Facilities Council HZB Helmholtz Zentrum Berlin



Surface Polishing
PEP

Surface Polishing



L. Vega Cid, TTC meeting 2022 (elaborated)

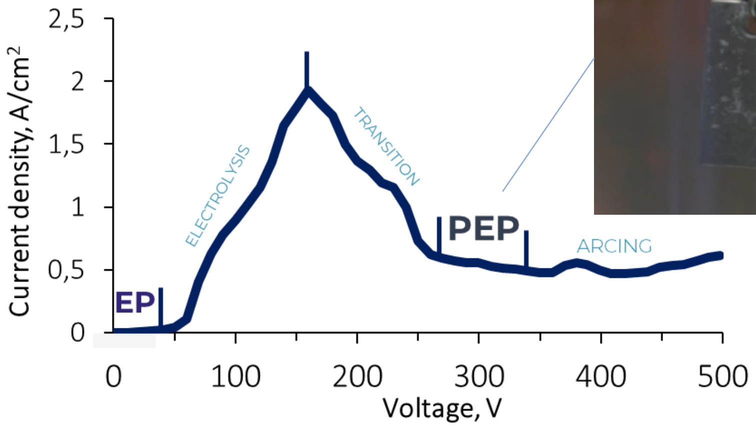
Cu substrate plays a fundamental role in SRF performances

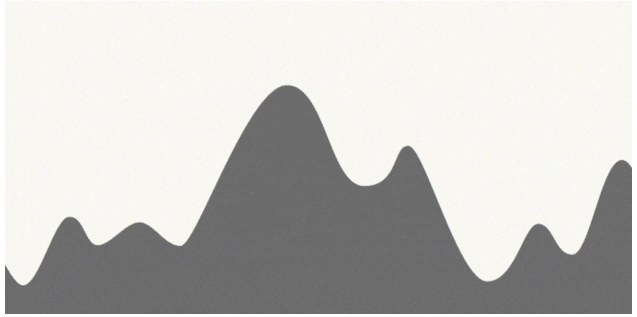
Roughness and defects reduction by **surface treatments are mandatory** for a good and uniform SRF coating

Cavity polishing requires **large amount of acids**. In particular **Nb** requires **HF** (extremely dangerous and poisoning process)

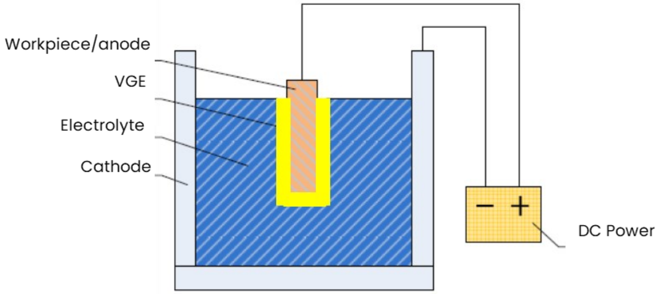
Plasma Electrolytic Polishing PEP

Mechanism



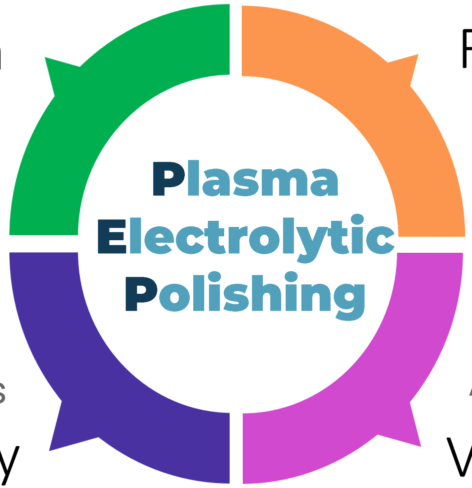


Same EP set-up
Different regime



J. Wang et al., AMR, 2012

Advantages



Green
Diluted water solutions, enviromentally friendly

Fast
The fastest non-destructive polishing

Efficiency
Equal thickness removal yield lowest roughness among competitors

Versatility
Less sensitive to the cathode shape! AM compatible

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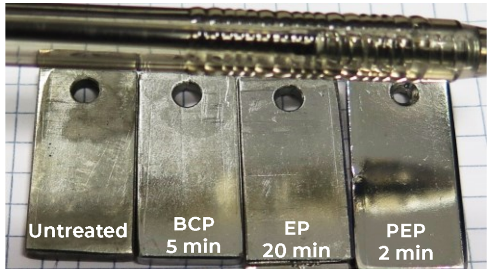
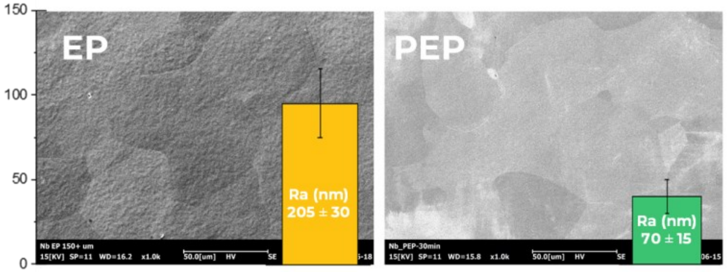
Plasma Electrolytic Polishing PEP Results

1x Nb 3x Cu
Solution Patents by INFN

Planar samples



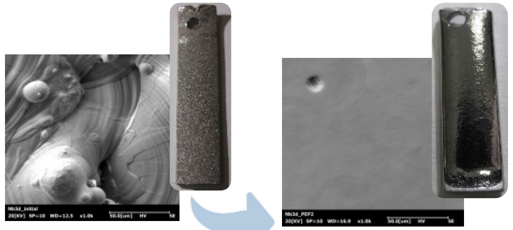
6.5 μm removed



150 μm removed in ~ 5 h

150 μm removed in ~ 40 min

Additive Manufacturing



Initial
Ra= 13 μm

PEP 30 min
Ra= 1.5 μm

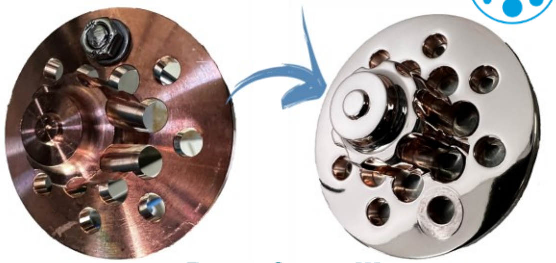
QPR Samples

Nb QPR polishing optimizaztion on-going

Full Cu QPR ready for coating

HZB Helmholtz Zentrum Berlin

Cu Photocatodes



DESY.

Ra ~ 8 nm!!!

6 GHz Cu cavity

Courtesy of E. Chyhyrynets

No internal cathode!

70 μm removed in 10 minutes

30 A (100 cm2 → 1.3 GHz ~ 300 A)

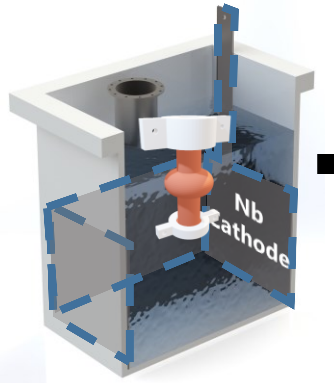
PEP Path to Final Prototype

Philosophy: scale 6 GHz set-up to 1.3 GHz converting LNL QWR polishing system

Priority: test RF performances after PEP

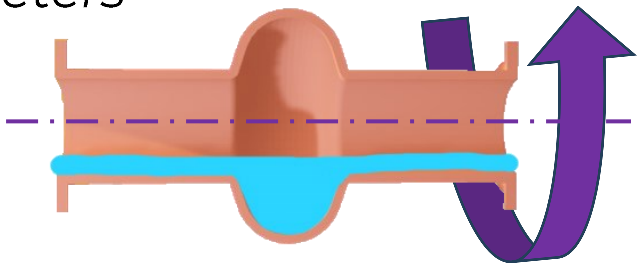
1. **Simpler set-up: cavity fully immersed**

2. **Alternative set-up to Reduce Process Power**
   - *Reduce Treated Area (rotating cavity)*
   - *Optimizing Process Parameters (Temperature, Voltage, ...)*



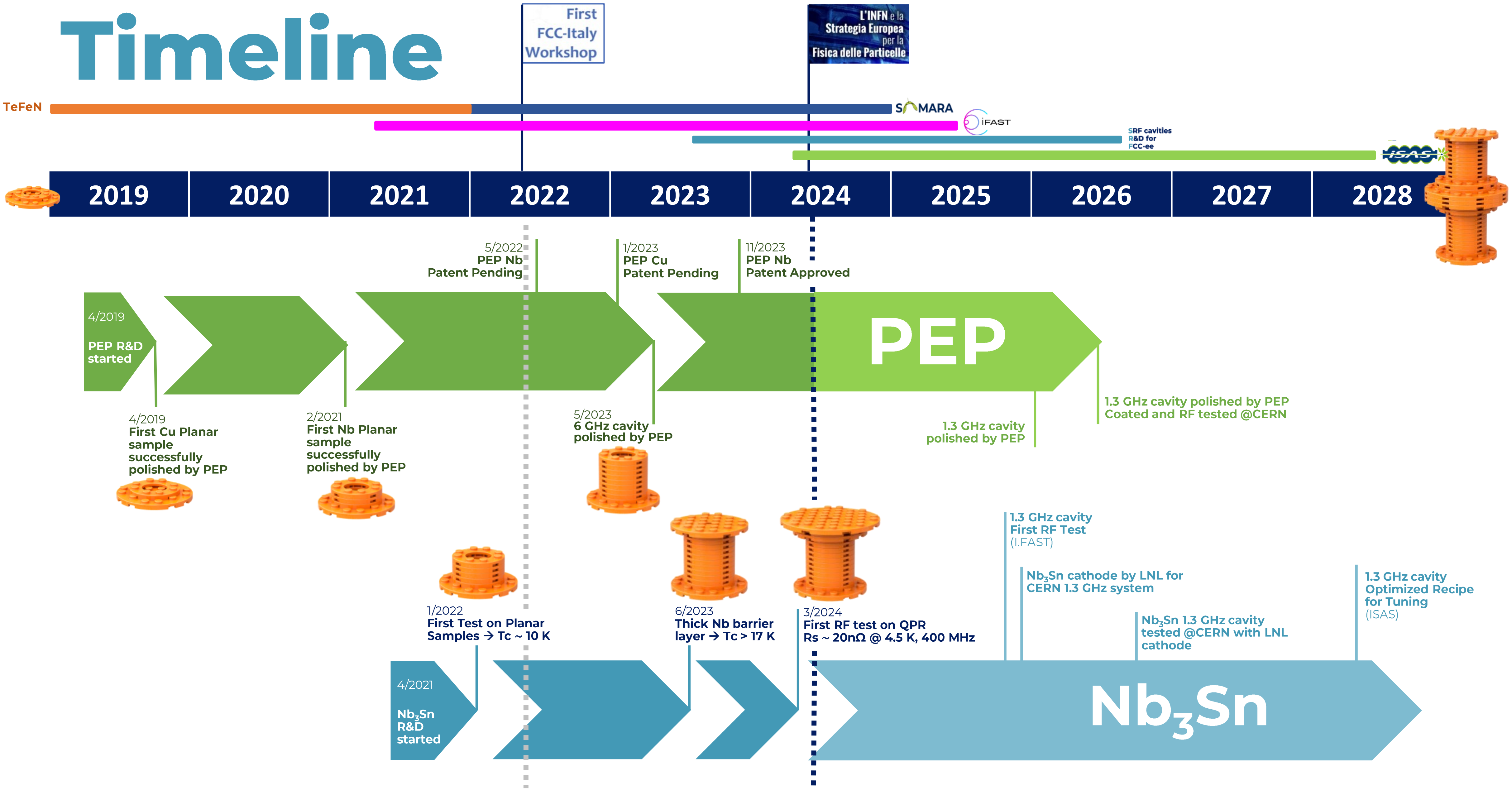
6 GHz - 30 L

1.3 GHz - 300 L



QWR Implant @LNL

Timeline



First FCC-Italy Workshop
L'INFN e la Strategia Europea per la Fisica delle Particelle
TeFeN
MARA
IFAST
SRF cavities R&D for FCC-ee
ISAS
2019
2020
2021
2022
2023
2024
2025
2026
2027
2028
5/2022 PEP Nb Patent Pending
1/2023 PEP Cu Patent Pending
11/2023 PEP Nb Patent Approved
4/2019 PEP R&D started
PEP
4/2019 First Cu Planar sample successfully polished by PEP
2/2021 First Nb Planar sample successfully polished by PEP
5/2023 6 GHz cavity polished by PEP
1.3 GHz cavity polished by PEP
1.3 GHz cavity polished by PEP Coated and RF tested @CERN
1.3 GHz cavity First RF Test (I.FAST)
Nb_3Sn cathode by LNL for CERN 1.3 GHz system
1.3 GHz cavity Optimized Recipe for Tuning (ISAS)
Nb_3Sn 1.3 GHz cavity tested @CERN with LNL cathode
1/2022 First Test on Planar Samples → Tc ~ 10 K
6/2023 Thick Nb barrier layer → Tc > 17 K
3/2024 First RF test on QPR Rs ~ 20nΩ @ 4.5 K, 400 MHz
4/2021 Nb_3Sn R&D started
Nb_3Sn

Conclusion

- **PEP and Nb_3Sn films** are possible **game changer technologies** for SRF accelerating cavities
- **Big steps forward** in the last two years with transition from planar to 3D samples
- **Very promising results from first RF test**
- **Validation with 1.3 GHz cavities is necessary** prior to evaluating the feasibility of implementing these technologies in FCC-ee or FCC-HH
- **End of 2025** we expect to have the **first tests** available on **1.3 GHz cavities**
- **In 2028 optimized prototypes** are expected

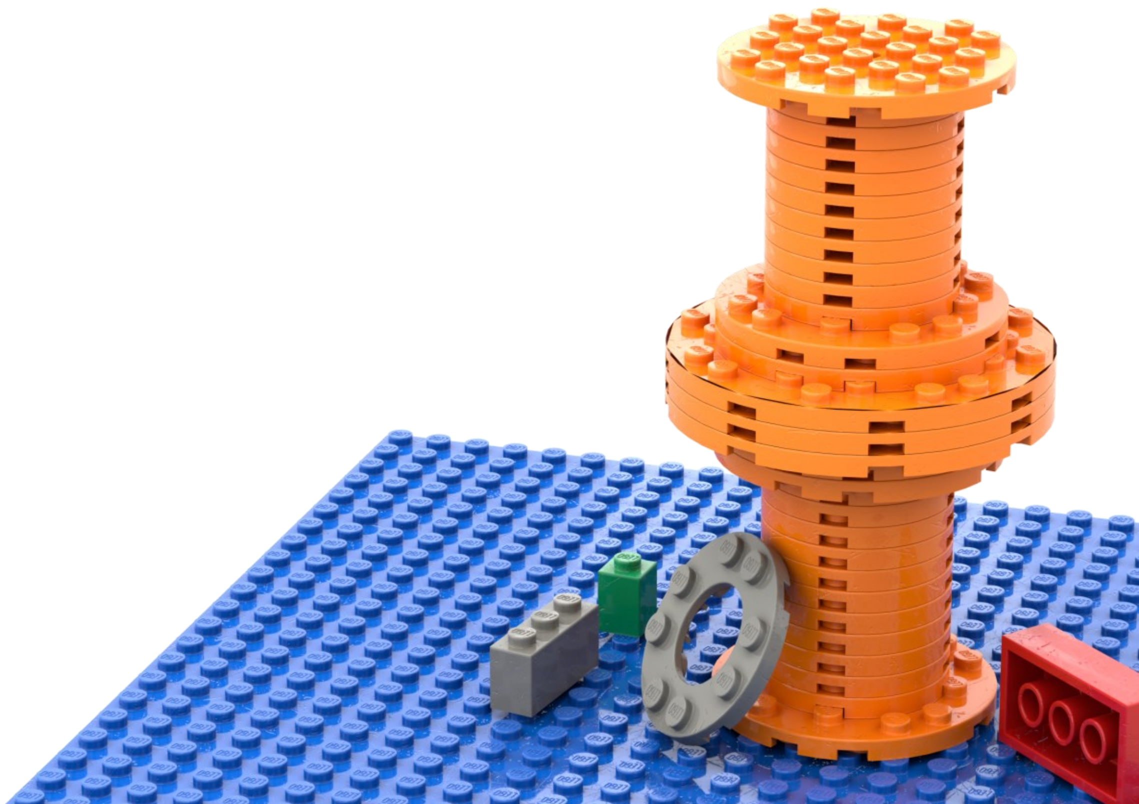
Work supported by INFN CSN5 experiment SAMARA and INFN CSN1 experiments SRF and RD_FCC
This project has received funding from the European Union’s Horizon-INFRA-2023-TECH-01 under GA No 101131435 – ISAS and from the European Union’s Horizon 2020 Research and Innovation programme under GA No 101004730 – I.FAST

Roma 6-7 Maggio 2024
Centro Congresso Frentani

INFN LNL

Cristian **Pira**

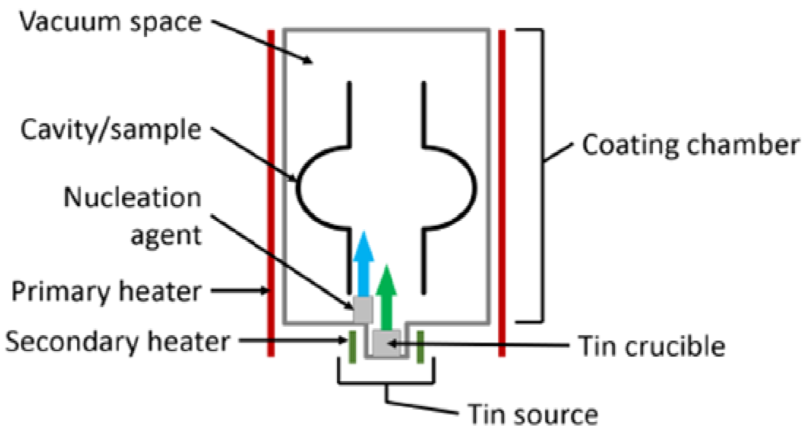
Backup Slides

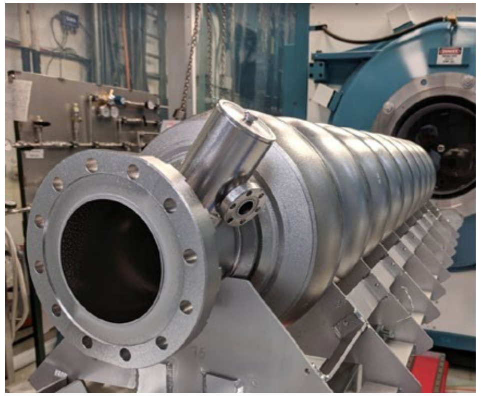


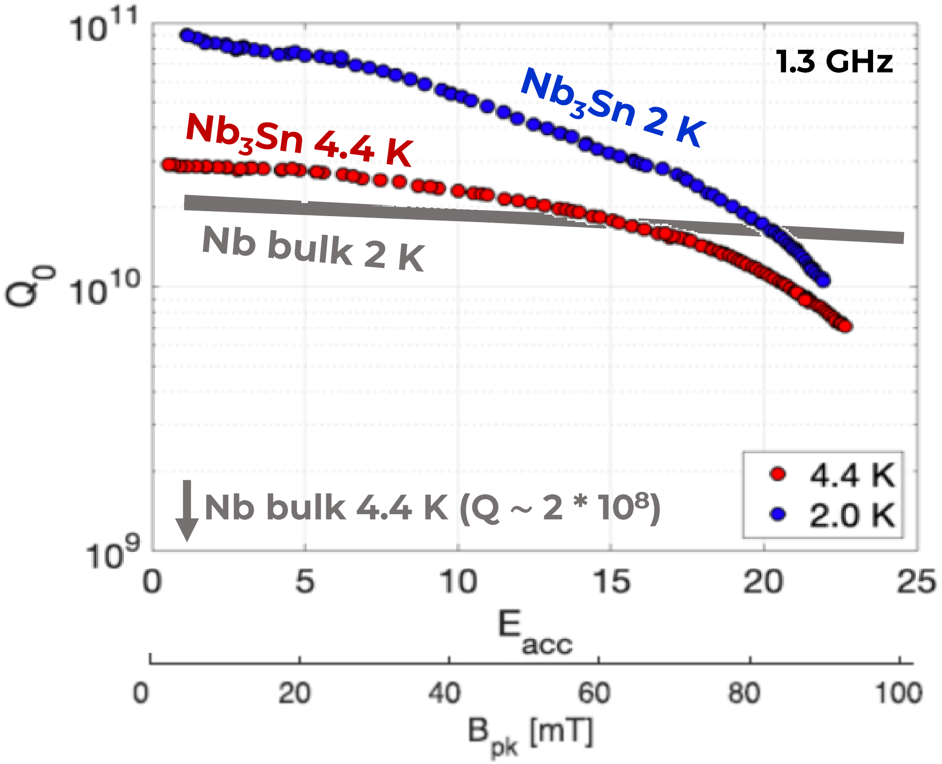
Nb_3Sn state of the art

Vapor Tin Diffusion

Cornell, Fermilab, JLab, KEK





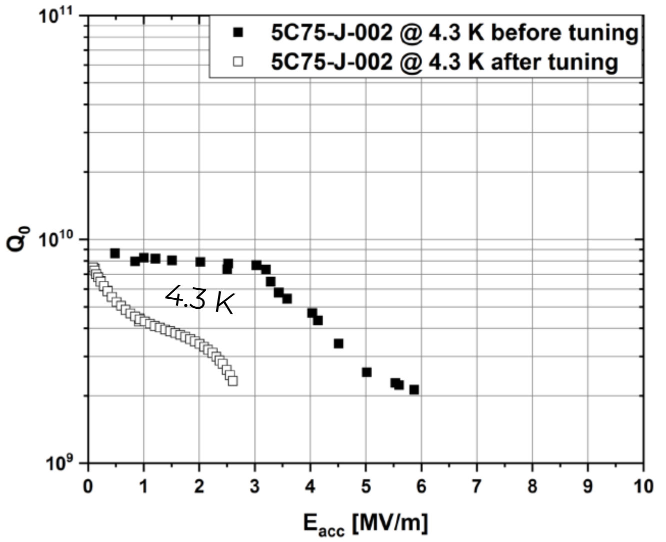


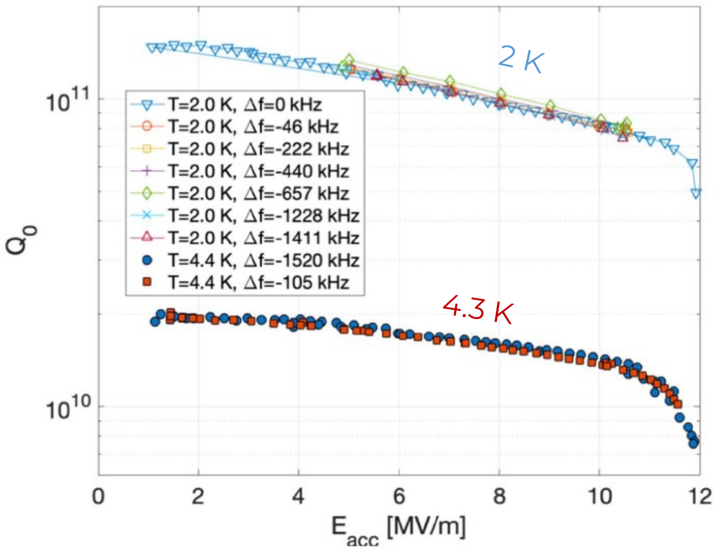
S. Posen, SRF 2019 proceedings (elaborated)

Technology limitation:

- **Reproducibility**
- **Substrate cost**

Cavity Tunability





Nb_3Sn is extramelly brittle

Eremeev, G. (2023). Tunability/robustness of Nb3Sn (No. FERMILAB-SLIDES-23-402-TD). Fermi National Accelerator Laboratory (FNAL), Batavia, IL (United States).

Strong performance degradation after **room temperature** tuning for 200 kHz

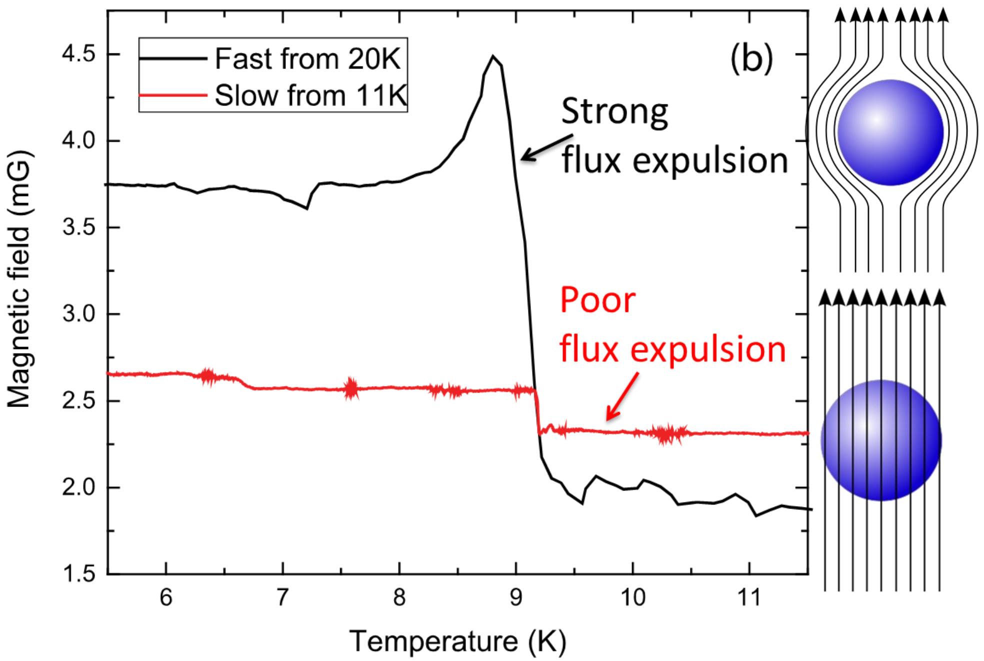
Little change in the coated cavity performance after tuning up to 1400 kHz at **cryogenic temperatures**

- **Vapor Tin Diffusion Nb_3Sn on Nb cavities can be tuned only at cryogenic T**
- **An interlayer in Nb_3Sn on Cu coatings can be added to enhance film mechanical stability and tunability**

Trapped Flux

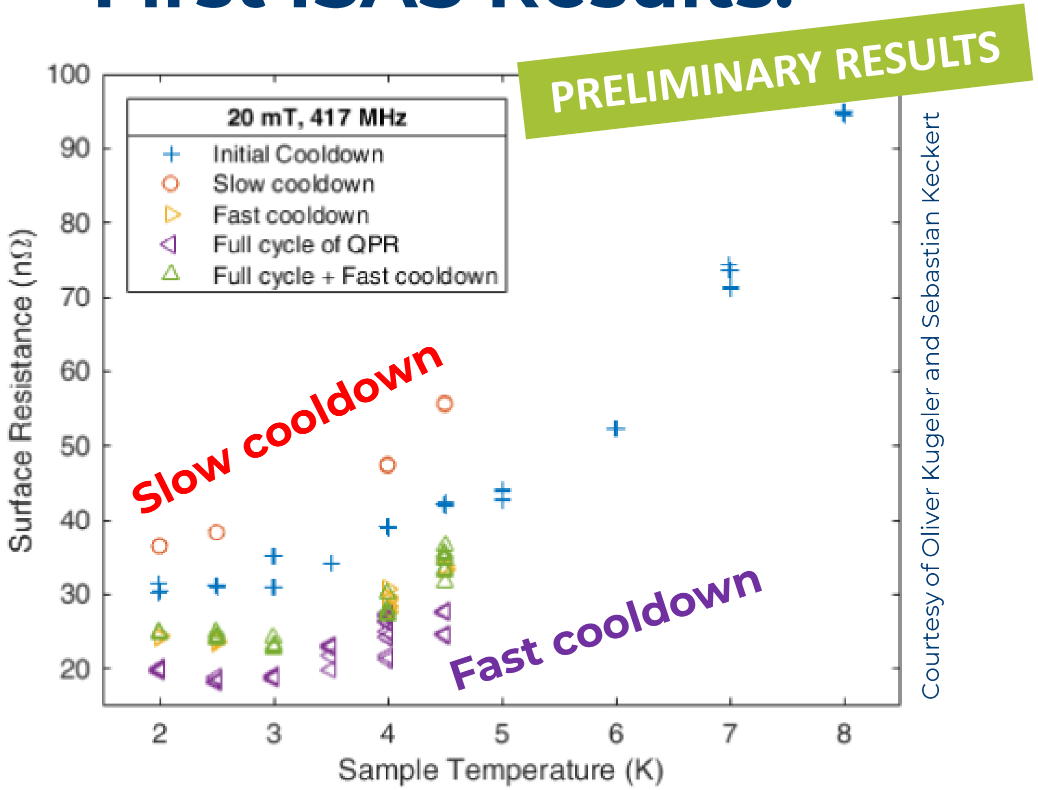
$$Q_0 \propto \frac{1}{R_{BCS} + R_{res} + \eta\, S\, B}$$

Fraction of Trapped Flux — Sensitivity



A. Romanenko, A. Grassellino, O. Melnychuk, D. A. Sergatskov, J. Appl. Phys. 115, 184903 (2014)

First ISAS Results:

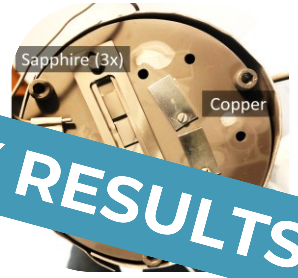


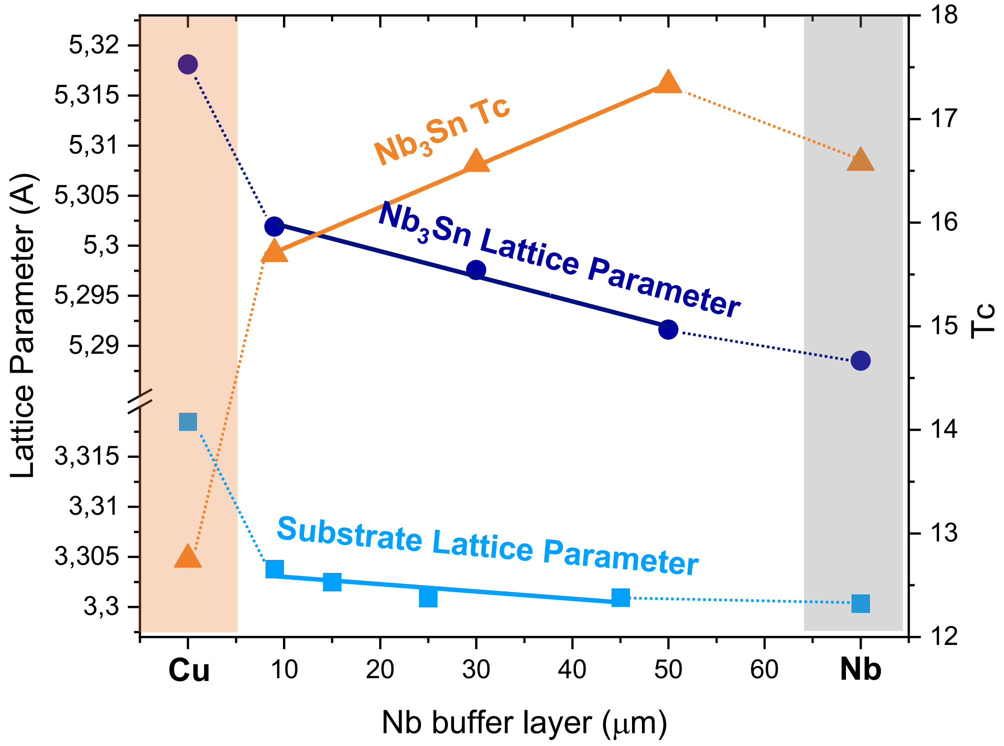
- Nb_3Sn coating suffer flux trapping
- Cooldown procedure influence Rs

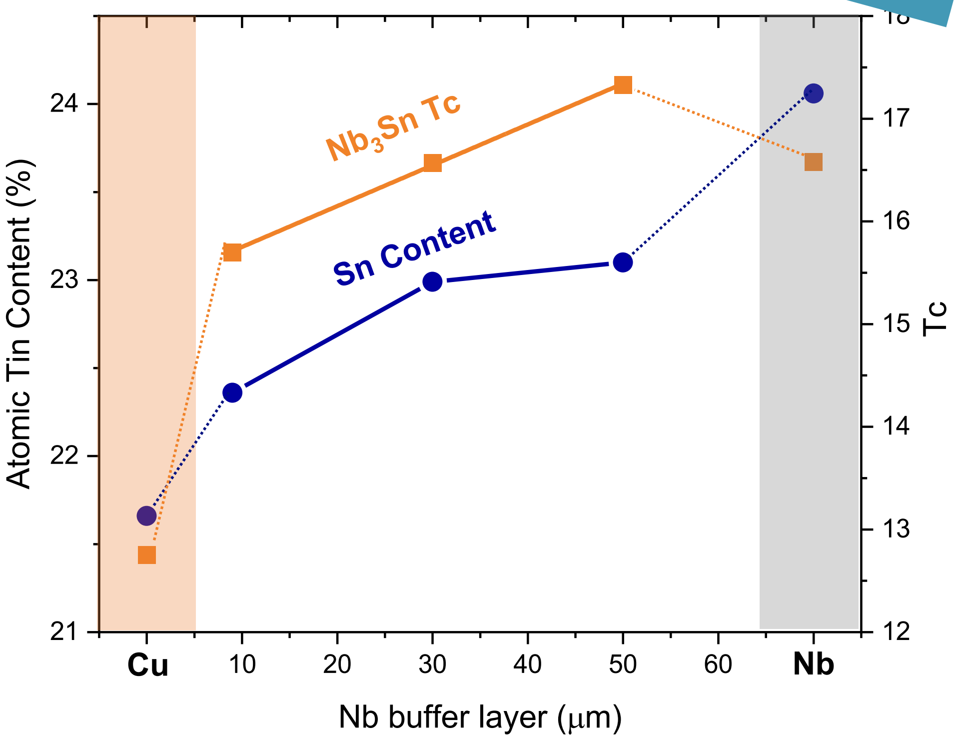
Nb_3Sn coatings

Sputtering parameter optimization

PRELIMINARY RESULTS





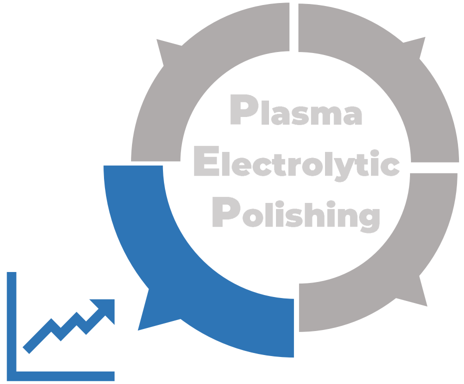


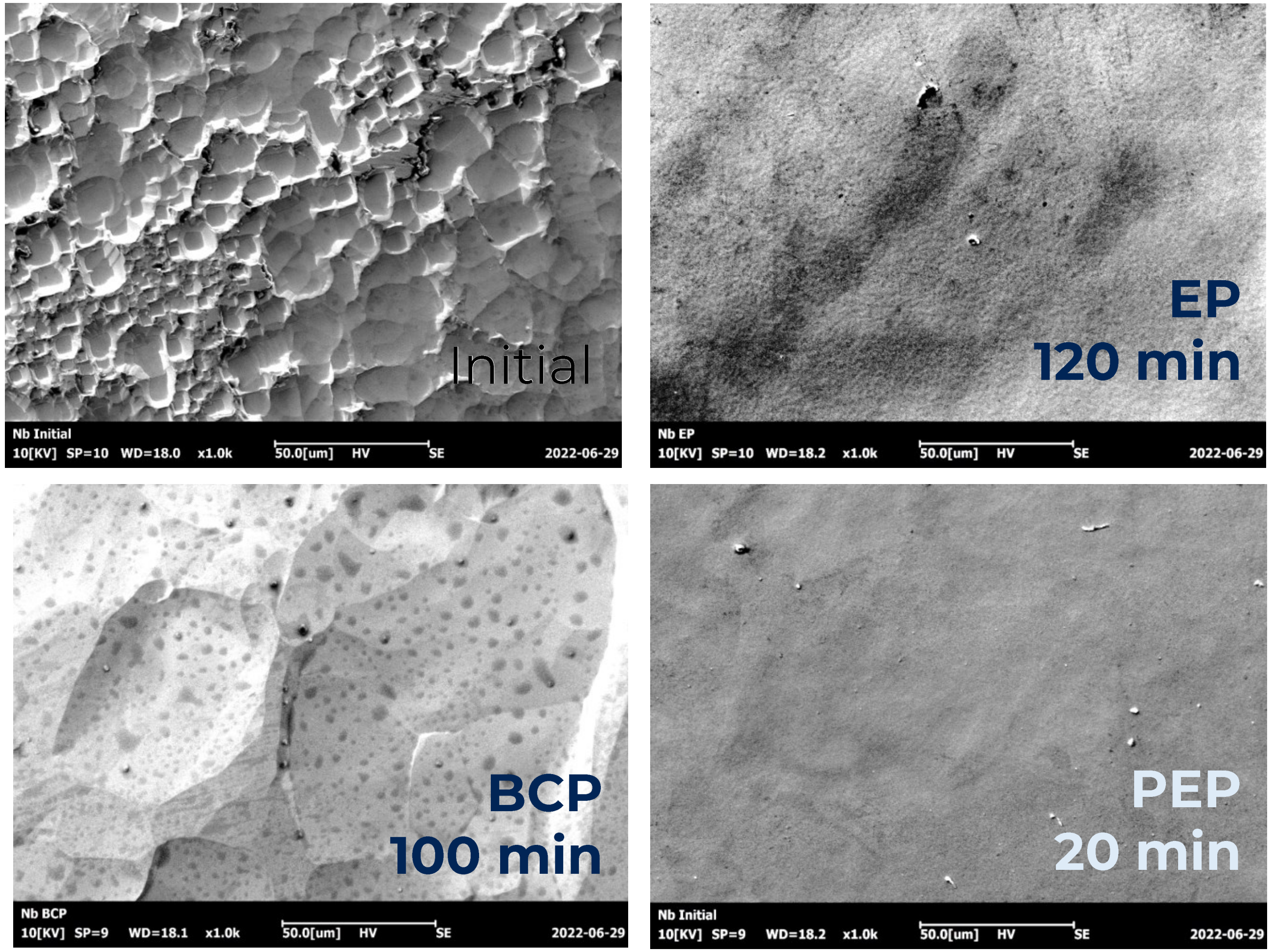
The role of the thick Nb layer is to accommodate the Nb_3Sn lattice parameter

ALD layer could be an alternative to explore

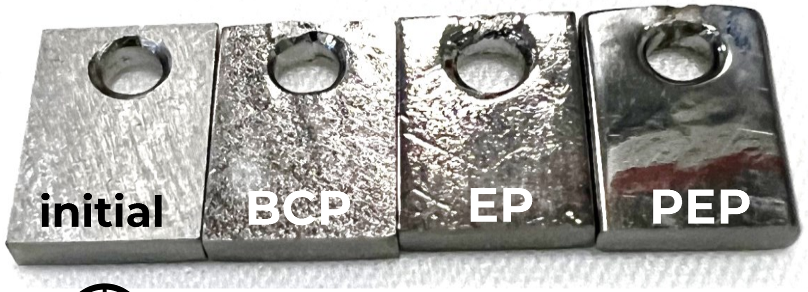
PEP is Efficient

Comparision with EP and BCP





Nb, Magnification **1000x**;
100 µm Removal



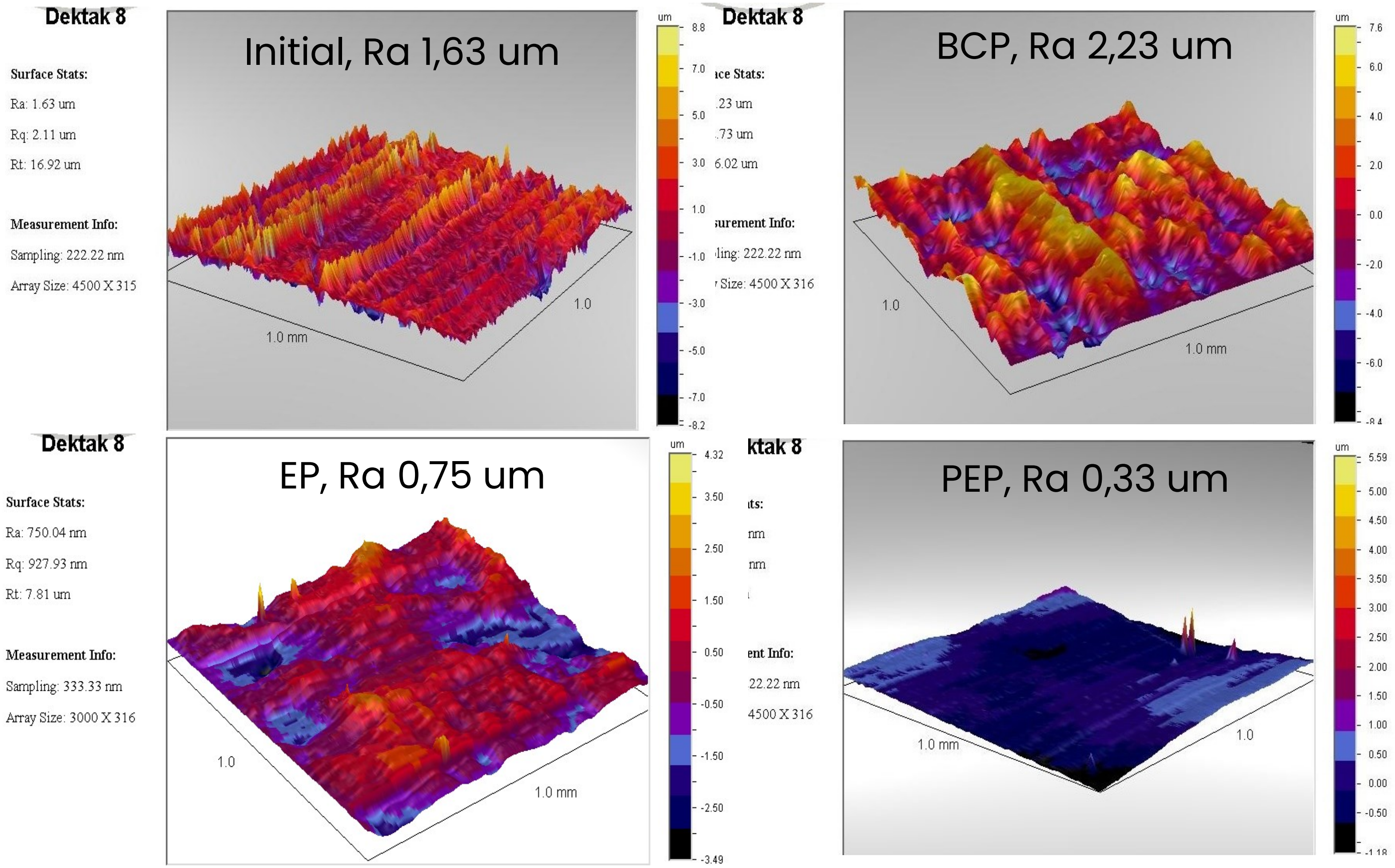
100 min | 120 min | 20 min

Both micro and macro **roughness is improved significantly**

cristian.pira@lnl.infn.it

PEP is Efficient

Comparision with EP and BCP



Nb, Magnification **1000x**;
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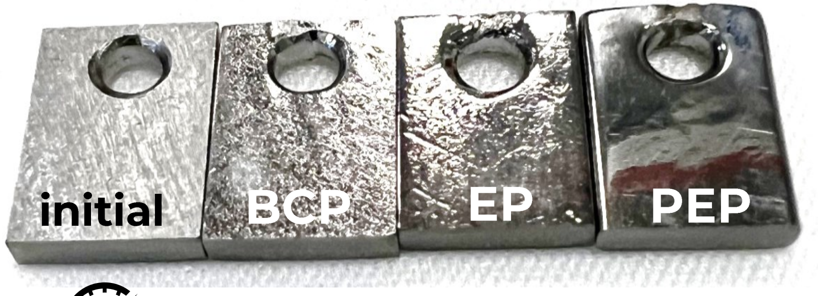

100 min | 120 min | 20 min

Both micro and macro **roughness is improved significantly**

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Comparison

Copper treatments

Process / parameters	"SUBU5"	EP (3:2)	PEP in "SUBU5"
Solution composition	Sulfamic acid 5 g/l; NH_4-citrate 1 g/l Butanol 50 ml/l; H_2O_2 50 ml/l	85 % H_3PO_4 60 p. 99% n-Butanol 40p.	Sulfamic acid 5 g/l; NH_4-citrate 1 g/l Butanol 50 ml/l; H_2O_2 50 ml/l
Voltage	-	2-6 V	300 V
Current density	-	0,01 – 0,03 A/cm²	0,25-0,8 A/cm²
Power draw	-	0,06 – 0,18 W/cm²	75 – 240 W/cm²
Removing rate	1,5 μm/min (70±2 ℃)	0,15-0,5 μm/min (25 ℃)	20-30 μm/min (80 ℃)

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